



IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

TM  
AF#

APPLICANT: Grigorian *et al.*

APPLICATION NO.: 09/825,870

FILING DATE: April 5, 2001

TITLE: CHEMICAL VAPOR DEPOSITION GROWTH OF SINGLE-WALL  
CARBON NANOTUBES

EXAMINER: Peter J. Lish

GROUP ART UNIT: 1754

ATTY. DKT. NO.: 23085-08328/US

**CERTIFICATE OF MAILING**

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Dated: April 1/2005

By: Narinder Banait  
Narinder Banait, Reg. No.: 43,482

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**AMENDMENT/RESPONSE (37 C.F.R. § 1.116)**

SIR:

Responsive to the Final Office Action dated December 1, 2004, received in the above-identified patent application, please enter the following amendments, and consider the accompanying remarks. As the response is being filed after three months of the date of mailing of the Office Action, this Amendment includes a request for an extension of time. Applicants respectfully requests reconsideration of the claims in the above-identified application in view of the following amendments and remarks for the purpose of putting the application in condition for allowance.